Notice of References Cited Application/Control No. 10/525,770 Applicant(s)/Patent Under Reexamination SHIRAI ET AL. Examiner Khoa D. Huynh Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
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FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001152520 A	06-2001	Japan	Yamazaki et al.	E03D 009/8
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